Gamma Radiation's Influence on TiO₂ in Iron Oxidation within Aqueous **Solution: Potential Photocatalytic Applications**

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The impact of the adsorption process, under gamma radiation, when

introducing TiO2 semiconductor into the Fricke solution containing Fe2+



Fe²⁺ → Fe³

Adsorption

and Fe³⁺ ions, was investigated. The crystalline phase, purity, particle size distribution, and specific surface area of TiO2 were measured. Based on experimental findings, it was observed that the pseudo second-order model offers a superior fit for the adsorption kinetics of both metal ions. Absorbed Additionally, the Freundlich model better describes the adsorption dose equilibrium of Fe²⁺ and Fe³⁺ onto TiO₂. To evaluate the influence of TiO₂ on Fricke solution, suspensions containing 0, 50, and 100 mg of TiO₂ were irradiated with 100, 250, and 500 Gy using a 60Co gamma source. The presence of TiO₂ in the Fricke solution alters the absorbed dose, likely attributable to the adsorption of Fe³⁺ ions onto TiO₂. Consequently, this indicates the need for additional experiments to quantify the reduction factor in absorbed dose resulting from this adsorption Kinetic and Equilibrium phenomenon. isotherm models

Introduction

Fricke

Solution

The Fricke solution serves to quantify the absorbed dose resulting from the interaction of gamma radiation with matter. Fricke dosimetry, also referred to as ferrous sulfate dosimetry, stands as one of the most extensively researched and commonly employed chemical dosimetry techniques [1]. This method hinges on the conversion of ferrous ions (Fe²⁺) to ferric ions (Fe³⁺) induced by ionizing radiation [2]. However, when this solution interfaces with a semiconductor such as titanium dioxide (TiO₂), the absorbed dose escalates owing to the generation of •OH radicals stemming from electron-hole pair formation on the semiconductor's surface. TiO₂ acts as a photosensitive semiconductor by absorbing electromagnetic radiation with enough energy to overcome its band gap [3].

Consequently, TiO₂ particles possess the capability to produce free radicals •OH and O^2 , rendering it widely applicable in organic matter decomposition, disinfection, and the elimination of viruses, bacteria, and other pathogens [4]. Extensive research has investigated the utilization of TiO₂ to enhance photocatalysis in water treatment processes [5].

Nonetheless, the adsorption mechanism and the impact of TiO₂ under gamma radiation on the Fricke solution remain unexplored, and this study aims to address that gap in research.

Material and Methods

The particle size, surface area, and purity of TiO₂ were analyzed using light scattering for particle size distribution, BET surface area measurement, and X-ray diffraction techniques. Fricke solutions were prepared following the ASTM E1026-04 standard. Fe2+ ions were measured according to Standard Method 3500-Fe B, while Fe³⁺ ions were determined using the thyocyanate colorimetric method.

For adsorption experiments, a suspension containing 10 g L⁻¹ of TiO₂ in 1 M solution of Fe²⁺ or Fe³⁺ was stirred at 300 rpm. Samples were taken at various time intervals ranging from 2 to 300 min. Each experiment was conducted in triplicate. Adsorption isotherms were constructed using TiO₂ masses ranging from 30 to 200 mg in 10 mL of Fricke solution containing either 0.5 M Fe²⁴ or Fe^{3+}. Solutions were filtered and maintained at $20 \pm 3^{\circ}C$ with constant agitation in the dark. Solutions were irradiated using a self-contained 60Co irradiator. The doses used were 100, 250, and 500 Gy and the TiO2 mass applied were 0, 50, and 100 mg. Absorbed dose values were the response variable, with six repetitions performed for each TiO₂ mass level.

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Results and Discussion

The results of the light scattering particle size distribution revealed that anatase is the dominant crystalline phase in the TiO₂; 80% of its particles are below 2.4 µm (d80), and 50% is below 1.4 µm (d50). XRD analysis indicated a purity of TiO₂ ranging from 99 to 100%. Additionally, BET analysis determined that specific surface area of TiO₂ was 111.203 m²/g.

Table 1 presents kinetic and equilibrium adsorption parameters for Fe²⁺ and Fe³⁺ using pseudo-first order, pseudo-second order, Freundlich, and Langmuir models, respectively. The data indicate that the adsorption kinetics of both Fe^{2+} and Fe^{3+} with TiO_2 fit better to the pseudosecond order model, with respective R² values of 0.9727 and 0.9610. In the Freundlich model, the adsorption capacity (K_F) is higher for Fe^{2+} compared to Fe^{3+} , while the adsorption intensity (represented by the exponent "n") is similar between Fe²⁺ and Fe³⁺. This suggests an inhomogeneous adsorption in multilayers due to an exponential distribution of active sites. The Langmuir model was discarded due to the obtaining of negative

values for Langmuir constant (K_L) for Fe^{2+} and Fe^{3+} individual systems, which lacks chemical sense.

Figure 1 illustrates the correlation between the absorbed dose and the dose administered by the ⁶⁰Co source across various masses of TiO₂. It is evident that the presence of TiO₂ has no discernible impact on the absorbed dose up to an irradiation dose of 250 Gy. However, the sensitivity of the Fricke solution containing TiO₂ with increasing absorbed dose under gamma radiation is affected.

The likely explanation for these findings is that the adsorption of Fe^{3+} onto the surface of TiO_2 could diminishes its absorbance value. Given that absorbance is directly correlated with the absorbed Fe^{3+} in the catalyst, rather than indicating an increase in the oxidation of Fe^{2+} to Fe^{3+} . Consequently, the absorbed dose decreases

compared to the measurement taken when there are no TiO_2 particles present in the Fricke solution.



Figure 1. Absorbed dose vs. dose by ⁶⁰Co source for Fricke solutions with and without TiO₂.

	Pseudo-first-order		Pseudo-second-order		Langmuir		Freundlich		
Metal ions	k1 (min ⁻¹)	\mathbf{R}^2	k_2 (g mmol ⁻¹ min ⁻¹)	\mathbf{R}^2	K _L (L mmol ⁻¹)	R ²	$\begin{array}{c} K_{F} \\ (mmol \ g^{\text{-}1} \\ mM^{\text{-}(1/n)}) \end{array}$	n	\mathbb{R}^2
Fe ²⁺	0.179	0.9354	34.547	0.9727	-2.5	0.9913	2.8x10 ⁸	0.037	0.9893
Fe ³⁺	0.219	0.9449	31.875	0.9610	-3.2	0.9800	3.4x10 ¹¹	0.037	0.9755

Table 1. Kinetic and equilibrium adsorption models parameters for adsorption of metal ions onto TiO2.

Conclusions

The interaction between gamma radiation and an aqueous solution containing a semiconductor solid, such as TiO₂, constitutes a form of heterogeneous photocatalysis. The TiO₂ utilized is in the crystalline phase of anatase, with a purity ranging from 99 to 100%. It possesses a particle size (d50) of $1.4 \,\mu$ m and a particle size (d80) of $2.4 \,\mu$ m, along with a specific surface area of 111.203 m²/g. Adsorption takes place when the semiconductor TiO₂ comes into contact with metallic ions Fe²⁺ and Fe³⁺ present in the Fricke solution. Both Fe²⁺ and Fe³⁺ individually exhibit pseudo-second-order kinetics when adsorbed onto TiO₂. The Freundlich model demonstrates a good fit for Fe²⁺ and Fe³⁺ systems with TiO₂. However, the Fricke dosimeter is found to be compromised in measuring the absorbed dose in the presence of TiO₂, primarily due to the adsorption of Fe³⁺ ions onto the TiO₂. Therefore, further experiments with higher irradiation doses are necessary to determine the extent of this adsorption phenomenon's impact on the absorbed dose.

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